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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Long-Sheng Liao)	Group Art No.:	2818
)		
Application No:	10/754,060)	Examiner:	Nguyen, Thinh T
)		
Filed:	01/07/2004)	Re:	Response
)		
For: "A Buffer Layer for Promoting Electron...")		Our Ref:	B-5346 621633-2
)			
)		Date:	February 22, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is filed in response to the official action dated February 4, 2005.

Remarks begin on page 2 of this paper.